Form 1449 (Modifi d)

JUL 1 5 2002

Information Disclosure
Statement By Applications

(Úse Several Sheets if Necessary)

Attorney Docket No:

LAM2P220C

09/747,844

U.S.

Applicant:

Kistler et al.

Filing Date:

December 21, 2000

Group:

3723

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	W					
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/		12/27/02				

Examiner: Initial citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.